

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68709

Minoru OGASAWARA, et al.

Appln. No.: 10/069,573

Group Art Unit: 1743

Confirmation No.: 1530

Examiner: Samuel P. Siefke

Filed: February 27, 2002

May 26, 2005

For:

HYDROGEN-FLAME PHOTOMETRIC ANALYZER FOR THIN-LAYER

CHROMATOGRAPH AND HYDROGEN-FLAME PHOTOMETRIC ANALYZING

METHOD

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 26, 2005, based on the filing herewith of a Petition For Extension Of Time extending the time for response to May 26, 2005, please amend the above-identified application as follows on the accompanying pages.

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